

**Notice of References Cited**

Application/Control No.

10/705,969

Applicant(s)/Patent Under  
Reexamination  
TANIGUCHI ET AL.

Examiner

David Y. Chung

Art Unit

2871

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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	B	US-6,147,725	11-2000	Yuuki et al.	349/65
	C	US-			
	D	US-			
	E	US-			
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	I	US-			
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	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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